
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Van Schravendijk, et al

Attorney Docket No.:

NOVLP037C1/NVLS-000519C1

Application No.: NEW

Examiner: UNASSIGNED

Filed: HEREWITH

Group: UNASSIGNED

Title: APPLICATIONS AND METHODS OF
MAKING NITROGEN-FREE ANTI-
REFLECTIVE LAYERS FOR
SEMICONDUCTOR PROCESSING

**INFORMATION DISCLOSURE STATEMENT
37 CFR §§1.56 AND 1.97(b)**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449 may be material to examination of the above-identified patent application. Applicants submit the list of these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application. The above-identified application is a Continuation of prior application U.S. Patent Application No. 09/990,197. This prior application is being relied upon for an earlier filing date under 35 U.S.C. § 120. Because the listed references were either cited by the PTO, or submitted to the PTO in the prior application, under 37 CFR § 1.98(d) Applicants submit that copies need not be provided.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is: (i) filed within three (3) months of the filing date of the above-referenced application, (ii) believed to be filed before the mailing date of a first Office Action on the merits, or (iii) believed to be filed before the mailing of a first Office Action after the filing of a Request for Continued Examination under §1.114. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. NOVLP037C1).

Respectfully submitted,

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Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty Docket No. NOVLP037C1/NVLS- 000519C1	Application No.: UNASSIGNED
	Applicant: van Schravendijk et al. Filing Date HEREWITH	Group UNASSIGNED

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A	6,251,770	6/26/01	Ugnow et al.	438	624	6/30/99
	B	6,051,282	4/18/00	Konjuh, et al.	427	539	6/4/98
	C	6,174,816	1/16/01	Yin et al.	438	705	4/6/00
	D	6,242,361	6/5/01	Lee et al.	438	710	12/13/99
	E	6,168,726	1/2/01	Li et al.	216	79	11/15/98
	F	6,316,167	11/13/01	Angelopoulos et al.	430	313	1/10/00
	G	6,235,456	5/22/01	Ibok	430	512	12/9/98
	H	6,156,640	12/5/00	Tsai et al.	438	636	7/14/98
	I	6,214,526	4/10/01	Sundararajan et al.	430	316	2/17/98

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	J							
	K							
	L							
	M							
	N							

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	O	
	P	
	Q	
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.